



ESW

**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: A8700

Lawrence SHAH, et al.

Appln. No.: 10/813,269

Group Art Unit: 2828

Confirmation No.: 5356

Examiner: Dung T. NGUYEN

Filed: March 31, 2004

For: FEMTOSECOND LASER PROCESSING SYSTEM WITH PROCESS PARAMETERS  
CONTROLS AND FEEDBACK

**RESPONSE TO NOTICE OF NON-COMPLIANT AMENDMENT (37 CFR § 1.121)**

**MAIL STOP AMENDMENT**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Notice dated October 20, 2006, Applicants are resubmitting herewith the "Remarks" section of the Response filed on October 13, 2006, as follows on the accompanying pages.

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